

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Isamu Kobori et al. Art Unit : 2811
Serial No. : 10/623,581 Examiner : Stanetta Isaac
Filed : July 22, 2003 Confirmation No.: 6534
Title : METHOD OF MANUFACTURING A SEMICONDUCTOR METHOD OF
MANUFACTURING A THIN-FILM TRANSISTOR AND THIN-FILM
TRANSISTOR

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

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OFFICE OF PETITIONS

PETITION TO WITHDRAW

Applicant hereby petitions under §1.313(c)(2) for the withdrawal of this application from issue to permit consideration of an Information Disclosure Statement filed in a continuing application. The issue fee was paid on March 14, 2006 and it is due to issue on May 9, 2006.

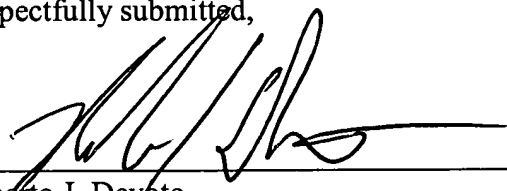
A request for continued examination (RCE) of this application under §1.114 is being filed simultaneously herewith. The request for continued examination is intended to continue this application on the grant of this petition.

Enclosed is a check for \$920 (\$130 in payment of the petition fee required by 1.17(i) and \$790 for the RCE). Please apply any other charges or credits to Deposit Account No. 06-1050.

Respectfully submitted,

Date: _____

5/2/06



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